



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: : Date: 9/3/04  
Schneider, et al. :  
Serial No: 10/701,233 : Group Art Unit: 3729  
Filed: November 3, 2003 :  
For: " Method for a Patterned Etch Using a Holographic : Examiner: unknown  
Mask"

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O.Box 1450  
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is being submitted pursuant to 37 C.F.R. §1.56 and §1.97.

The Examiner is requested to consider and make of record the references cited on the accompanying Form PTO-1449.

This Information Disclosure Statement should not be construed as a representation that a search has been made, nor should it be construed as an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b).

If any fees are required, please charge them to Deposit Account No. 22-0265. This form is submitted in duplicate.

Respectfully submitted,

Steven M. Mitchell  
Reg. No. 31,857  
Attorney for Applicant

PACESETTER, INC.  
701 E. Evelyn Avenue  
Sunnyvale, CA 94086  
Telephone: (408) 522-6101  
Date: 9/3/04

I hereby certify that this correspondence is being deposited  
in the United States Postal Service as First Class Mail in an  
envelope addressed to the Honorable Commissioner  
for Patents, Mail Stop: IDS, P. O. Box 1450  
Alexandria, VA 22313-1450 on Sept. 3, 2004.

[illegible]